

Electronic Acknowledgement Receipt

EFS ID:	3928447
Application Number:	09546174
International Application Number:	
Confirmation Number:	4793
Title of Invention:	HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION PROCESS
First Named Inventor/Applicant Name:	Chih-Chien Liu
Customer Number:	26021
Filer:	William H. Wright
Filer Authorized By:	
Attorney Docket Number:	JIA 462C1
Receipt Date:	11-SEP-2008
Filing Date:	11-APR-2000
Time Stamp:	16:44:42
Application Type:	Utility under 35 USC 111(a)

Payment information:

Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$630
RAM confirmation Number	2150
Deposit Account	150665
Authorized User	

The Director of the USPTO is hereby authorized to charge indicated fees and credit any overpayment as follows:

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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/Message Digest	Multi Part/.zip	Pages (if appl.)
1	Extension of Time	20952-4002-ExtOfTime.pdf	56815 9b:9f16f174a400205166160209620:00406 9caaf	no	2

Warnings:

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Information:

2	Appeal Brief Filed	20952-4002-AppealBrief.pdf	1181596 @391e0ddfece79b196e945cd11957217 1426	no	40
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Information:

3	Fee Worksheet (PTO-06)	fee-info.pdf	32210 3460986a9f03a6f0104094645831e06148 dftb	no	2
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Information:

Total Files Size (in bytes): 1270621

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New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

New International Application Filed with the USPTO as a Receiving Office

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.